



Express Mail No. EV551882855US

Attorney Docket No. 108298724US  
Disclosure No. 02-1202.00/US

### AMENDMENT TRANSMITTAL LETTER

Docket No.  
108298724US

Application No.  
10/665,964-Conf. #8350

Filing Date  
September 18, 2003

Examiner  
S. L. McDonald

Art Unit  
3723

Applicant(s): Taylor et al.

Invention: METHODS FOR REMOVING DOPED SILICON MATERIAL FROM MICROFEATURE WORKPIECES

#### TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	48	- 48 =	0	x	
Independent Claims	4	- 4 =	0	x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Extension for response within first month					120.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					120.00

☒ Large Entity

☐ Small Entity

☐ No additional fee is required for this amendment.

☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.

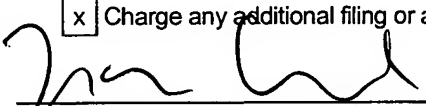
☒ A check in the amount of \$ 120.00 to cover the filing fee is enclosed.

☐ Payment by credit card. Form PTO-2038 is attached.

☒ The Director is hereby authorized to charge and credit Deposit Account No. 50-0665 as described below.

☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

  
John M. Wechkin  
Attorney Reg. No.: 42,216

Dated: March 21, 2005

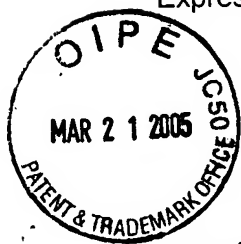
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03-23-05

IFW #

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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: THEODORE M. TAYLOR AND  
STEPHEN J. KRAMER

APPLICATION No.: 10/665,964

FILED: SEPTEMBER 18, 2003

FOR: **METHODS FOR REMOVING DOPED  
SILICON MATERIAL FROM  
MICROFEATURE WORKPIECES**

EXAMINER: SHANTESE L.  
MACDONALD

ART UNIT: 3723

CONF. No: 8350

**Amendment Under 37 C.F.R. § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated November 30, 2004 in the above-identified application. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.